
OLIFF & BERRIDGE, PLC

ATTORNEYS AT LAW

Application Data Sheet**Application Information**

Application Type:: Regular
Subject Matter:: Utility
CD-ROM or CD-R:: None
Title:: PRODUCTION METHOD OF SYNTHETIC SILICA
GLASS AND THERMAL TREATMENT
APPARATUS
Attorney Docket Number:: 109067.01
Suggested Drawing Figure::
Total Drawing Sheets:: 22
Small Entity:: No

Applicant Information

Applicant Authority type:: Inventor
Primary Citizenship Country:: Japan
Status:: Full Capacity
Given Name:: Shouji
Middle Name::
Family Name:: YAJIMA
Name Suffix::
City of Residence:: Sagamihara-shi
State or Province of Residence:: Kanagawa-ken
Country of Residence:: Japan

Applicant Authority type:: Inventor
Primary Citizenship Country:: Japan
Status:: Full Capacity
Given Name:: Hiroyuki
Middle Name::

Family Name::	HIRAIWA
Name Suffix::	
City of Residence::	Yokohama-shi
State or Province of Residence::	Kanagawa-ken
Country of Residence::	Japan
Applicant Authority type::	Inventor
Primary Citizenship Country::	Japan
Status::	Full Capacity
Given Name::	Yasuji
Middle Name::	
Family Name::	ISHIDA
Name Suffix::	
City of Residence::	Tuki-gun
State or Province of Residence::	Kanagawa-ken
Country of Residence::	Japan

Correspondence Information

Correspondence Customer Number:: 25944

Domestic Priority Information			
Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application is a	Division of	09/806,236	03/28/01
Which is a	National Stage of	PCT/JP00/05412	08/11/00
Foreign Priority Information			
Country::	Application Number::	Filing Date::	Priority Claimed::
Japan	P1999-228197	08/12/99	Yes

Assignee Information	
Assignee Name::	NIKON CORPORATION
Street of mailing address::	2-3 Marunouchi 3-chome
	Chiyoda-ku, Tokyo 100-8331 Japan
City of mailing address::	
State or Province of mailing address::	
Country of mailing address::	Japan
Postal or Zip Code of mailing address::	100-8331